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# IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: TAKEMORI, Toshiyuki et al.

Group Art Unit: 2814

PADEMAN Corial

Serial No.: 09/660,439

Examiner: Steven H. RAO

Filed: September 12, 2000

P.T.O. Confirmation No.: 6603

For: TRANSISTOR AND METHOD OF MANUFACTURING THE SAME

## AMENDMENT TRANSMITTAL

Commissioner for Patents Washington, D.C. 20231

March 13, 2003

Sir:

Transmitted herewith is an Amendment in the above-identified application. The fee has been calculated as shown below:

	CLAIMS AS AMENDED			TENTAL TOTAL TOTAL			
	Claims Remaining After Amendment	Highest Number Previously Paid For		Present Extra	Small Entity	Large Entity	Additional Fee
Total Claims	17	19	=	0	X \$9	X \$18	.00
	6	3	=	3	X \$42	X \$84	252.00
Independent Claims 6 3 1 2 3 1						280	0.00
TOTAL FEES ENCLOSED:							252.00

- $\underline{XX}$ . Enclosed please find our check in the amount of \$252.00 for the additional claims fee in connection with this amendment.
- The Commissioner is hereby authorized to charge payment for any additional fees associated with this communication or credit any overpayment to Deposit Account No. <u>01-2340</u>.

Respectfully submitted,

ARMSTRONG, WESTERMAN & HATTORI, LLP

Mel R. Quintos

Attorney for Applicants

Reg. No. 31,898

MRQ:lrj

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PATENT TRADEMARK OFFICE

MAR 1 3 2003

### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

17|c 318-03 Group Art Unit: 2814

In re the Application of: TAKEMORI, Toshiyuki et al.

Serial No.: 09/660,439

Filed: September 12, 2000

Examiner: Shrinivas (Steven) H. RAO

P.T.O. Confirmation No.: 6603

TRANSISTOR AND METHOD OF MANUFACTURING THE SAME For:

#### PRELIMINARY AMENDMENT

Commissioner for Patents Washington, D.C. 20231

March 13, 2003

Sir:

This is a Preliminary Amendment filed along with the Request for Continued Examination (RCE) filed March 13, 2003. Please amend the above-identified application as follows:

IN THE CLAIMS:

Claims 1 and 11 have been amended as follows:

1.

(Twice Amended) A transistor comprising:

a semiconductor substrate having a semiconductor layer, a drain layer of a first conductivity type provided on said semiconductor layer and a conductive region of a second conductivity type formed by diffusing an impurity of the second conductivity type from a surface of said drain layer;

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